

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/810,575	PARK, DAE-SUNG
	Examiner Michael A. Friedhofer	Art Unit 2832

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
200	61.58r	11/3/2005	MAF
200	61.62	11/3/2005	MAF
200	61.41	11/3/2005	MAF
200/61.42-61.44,61.7- 61.73; 335/205-207		11/3/2005	MAF